

Notice of References Cited	Application/Control No. 10/591,505		Applicant(s)/Patent Under Reexamination HIRMER ET AL.	
	Examiner Monique R. Jackson		Art Unit 1787	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,066,581	05-2000	Chivukula et al.	501/12
*	B	US-6,247,799	06-2001	Sakamaki et al.	347/68
*	C	US-2003/0128496	07-2003	Allen et al.	361/306.3
*	D	US-6,271,273	08-2001	You et al.	521/61
*	E	US-6,420,441	07-2002	Allen et al.	521/77
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	I					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Zhang et al, Self-buffered SaxSr1-xTiO3 films by sol-gel and RF magnetron sputtering method, Materials Research Bulletin 38, 2003, p133-139.
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.